

Notice of References Cited	Application/Control No. 10/625,065	Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner George A. Goudreau	Art Unit 1763	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0235262	11-2004	Lee et al.	438/411
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	FR 2,799,307	04-2001	France	Bois et. al.	-----
	O	WO 200,057,480	09-2000	WO	Jurczak et. al.	-----
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Silicon On Nothing (SON)-Fabrication, Material and Devices"; Proceedings-Electrochemical Society volume 2001-3; (2001); pp. 391-402; Skotnicki
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.